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Attorney Docket No. 5649-1226

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: **Kim et al.**

Serial No.: **10/806,521**

Filed: **March 23, 2004**

For: **METHOD OF FABRICATING A SEMICONDUCTOR SUBSTRATE FOR  
REDUCING WAFER WARPAGE**

Confirmation No.: **2748**

Group Art Unit: **2812**

Examiner: **Walter Lee Lindsay, Jr.**

Date: December 9, 2005

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**  
**MAILED SEPTEMBER 19, 2005**

Sirs:

Applicants provide the present Amendment to address the issues raised in the Office Action mailed September 19, 2005 (the Action).

It is not believed that an extension of time and/or additional fee(s), including fees for additional claims, are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

A listing of claims begins on page 2.

The Remarks begin on page 6.